

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANT: Roman Chistyakov  
SERIAL NO.: 10/065,277                      GROUP NO.: 1753  
FILING DATE: September 30, 2002              EXAMINER: McDonald, Rodney G.  
TITLE: HIGH-POWER PULSED MAGNETRON SPUTTERING

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**RESPONSE**

Sir:

The following remarks are responsive to the Office Action mailed on July 18, 2006 in the above-identified patent application. Entry and consideration of the following amendments and remarks, and allowance of the claims, as presented, are respectfully requested.

Remarks are on page 2 of this paper.